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10595323 GAU: 1715

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(Not for submission under 37 CFR 1.99)

Application Number		
Filing Date		2006-04-07
First Named Inventor	Pier John Anthony Sazio	
Art Unit		
Examiner Name		
Attorney Docket Number	DYOUP0313US	

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7	HOLMES, JUSTIN D. et al. "Control of Thickness and Orientation of Solution-Grown Silicon Nanowires." Science. 287 (February 25, 2000): 1471-1473.	<input type="checkbox"/>
8	COLEMAN, NICHOLAS R.B. et al. "The formation of dimensionally ordered silicon nanowires within mesoporous silica." Journal of the American Chemical Society. 123 (2001): 187-188.	<input type="checkbox"/>
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10	VLASOV, YU. A. et al. "Enhancement of optical gain of semiconductors embedded in three-dimensional photonic crystals." Applied Physics Letters. 71.12 (September 22, 1997): 1616-1618.	<input type="checkbox"/>
11	KAZES, MIRI et al. "lasing from semiconductor quantum rods in a cylindrical microcavity." Advanced Materials. 14.4 (February 19, 2002): 317-321.	<input type="checkbox"/>
12	FOKINE, M. et al. "Integrated fiber Mach-Zehnder interferometer for electro-optic switching." Optics Letters. 27.18 (September 15, 2002): 1643-1645.	<input type="checkbox"/>
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